

Notice of References Cited

Application/Control No.

10/539,572

Applicant(s)/Patent Under

Reexamination

VIELLEROBE ET AL.

Examiner

David N. Werner

Art Unit

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U.S. PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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U	Goehde, W. et al. "A Low-Temperature Scanning Confocal and Near-Field Optical Microscope". <u>Review of Scientific Instruments</u> _ 68.6 (June 1997): 2466-2474.
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